

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket Number (Optional) <b>50478-4200</b>		Application Number <b>Not yet assigned</b>			
				Applicant(s) <b>Jun Hashimoto et al.</b>				<b>10/594145</b>	
				Filing Date <b>Herewith</b>					
				Group Art Unit <b>Not yet assigned</b>					
<b>U. S. PATENT DOCUMENTS</b>									
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
		6,788,373	9.7.2004	Ito et al.					
		6,242,864	6.5.2001	Nakahara et al.					
		6,879,107	4.12.2005	Hirano et al.					
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>									
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
		2004/0070341	4.15.2004	Chul Park					
<b>FOREIGN PATENT DOCUMENTS</b>									
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES      NO		
		2004-031264	1.29.2004	Japan w/English Abstract			X		
		2002-33053	1.31.2002	Japan (See USP 6788373 family patent)			X		
		10-334809	12.18.1998	Japan (See USP 6,242,864 family patent)			X		
		2003-31136	1.31.2003	Japan (See USP 6,897,107 family patent)			X		
		2004-103273	4.2.2004	Japan w/English Abstract			X		
		2002-069617	3.8.2002	Japan w/English Abstract			X		
		2003-272533	9.26.2003	Japan w/English Abstract			X		
		2004-011014	1.15.2004	Japan w/English Abstract			X		
		2003-022755	1.24.2003	Japan w/English Abstract			X		
		2004-134407	4.30.2004	Japan (See US 2004/0070341 family application)			X		
		9-259894	11.18.1997	Japan w/English Abstract			X		
		9-92133	4.4.1997	Japan w/English Abstract			X		
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>									
EXAMINER				DATE CONSIDERED					
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